

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	17	ceramic with chuck same prob\$4 same nitride	US-PGPUB; USPAT	OR	ON	2004/12/04 18:05
S2	2080	electrostatic near chuck with wafer	US-PGPUB; USPAT	OR	ON	2004/12/04 18:05
S3	57	electrostatic near chuck with wafer with nitride	US-PGPUB; USPAT	OR	ON	2004/12/04 18:06
S4	9	electrostatic near chuck with wafer with nitride with (inspect\$4 prob\$4 test\$4)	US-PGPUB; USPAT	OR	ON	2004/12/04 18:10
S5	0	ceramic near chuck with wafer with nitride with (inspect\$4 prob\$4 test\$4)	US-PGPUB; USPAT	OR	ON	2004/12/04 18:10
S6	2	ceramic near2 chuck with wafer with nitride with (inspect\$4 prob\$4 test\$4)	US-PGPUB; USPAT	OR	ON	2004/12/04 18:12
S7	6	chuck with wafer with nitride with prob\$4	US-PGPUB; USPAT	OR	ON	2004/12/04 18:11
S8	24	ceramic with wafer with nitride with (inspect\$4 prob\$4 test\$4)	US-PGPUB; USPAT	OR	ON	2004/12/04 18:12
S9	16	ceramic with wafer with nitride with prob\$4	US-PGPUB; USPAT	OR	ON	2004/12/04 18:13
S10	8	ceramic with wafer with nitride with test\$4	US-PGPUB; USPAT	OR	ON	2004/12/04 18:20
S11	4	ceramic with wafer with nitride with inspect\$4	US-PGPUB; USPAT	OR	ON	2004/12/04 18:23
S12	0	S9 and S10 and S11	US-PGPUB; USPAT	OR	ON	2004/12/04 18:13
S13	3	S9 and S10	US-PGPUB; USPAT	OR	ON	2004/12/04 18:13
S14	46	("4159075" "4273282" "4962441" "5055964" "5280156" "5324053" "5413360" "5539609").PN. OR ("5886863").URPN.	US-PGPUB; USPAT; USOCR	OR	OFF	2004/12/04 18:32
S15	133	ceramic and heat adj conductor and wafer	US-PGPUB; USPAT	OR	OFF	2004/12/04 19:14
S16	21	ceramic same heat adj conductor and wafer	US-PGPUB; USPAT	OR	OFF	2004/12/04 19:26
S17	9	ceramic and heat adj conductor with wafer	US-PGPUB; USPAT	OR	OFF	2004/12/04 19:25
S18	0	ceramic with chuck and heat adj conductor with layer	US-PGPUB; USPAT	OR	OFF	2004/12/04 19:25
S19	1741	electrostatic and chuck and ceramic and wafer	US-PGPUB; USPAT	OR	OFF	2004/12/04 19:26

S20	1571	electrostatic and chuck and ceramic and wafer and (heat tempera\$4)	US-PGPUB; USPAT	OR	OFF	2004/12/04 19:27
S21	1377	electrostatic adj chuck and ceramic and wafer and (heat tempera\$4)	US-PGPUB; USPAT	OR	OFF	2004/12/04 19:27
S22	11	electrostatic adj chuck and ceramic and wafer and (heat tempera\$4) and "324"/\$.ccls.	US-PGPUB; USPAT	OR	OFF	2004/12/06 11:33
S23	4	((("4599559") or ("5600257") or ("4567432") or ("4161692"))).PN.	US-PGPUB; USPAT	OR	OFF	2004/12/06 12:18
S25	1	S23 and nitride	US-PGPUB; USPAT	OR	OFF	2004/12/06 11:45
S26	1	("4301324").PN.	US-PGPUB; USPAT	OR	OFF	2004/12/06 12:18